

swiss scientific initiative in health / security / environment systems

3D – Large Scale Integration of Sensors into Smart Textile

3D-SensTex

D. Briand¹, G. Mattana¹, A. Vasquez Quintero¹, M. Camara¹, Z. Szamel², M. Schnieper²,

G. A. Salvatore³, L. Petti³, N. Muzenrieder³, P. Chabrecek⁴, G. Tröster³, N. F. de Rooij¹



FÉDÉRALE DE LAUSANNE

ETH

Eidgenössische Technische Hochschule Zürich Swiss Federal Institute of Technology Zurich

FNSNE

cross-section

(MPa) 05

Ecole Polytechnique Fédérale de Lausanne (EPFL), Institute of Microengineering (IMT), Sensors, Actuators and Microsystems Laboratory (SAMLAB), Neuchâtel, Switzerland.

- Centre Suisse d'Electronique et de Microtechnique SA (CSEM SA), Muttenz, Switzerland.
- Eidgenössische Technische Hochschule Zürich (ETHZ), Wearable Computing Laboratory, Zurich, Switzerland. 3.
- SEFAR AG, Heiden, Switzerland.

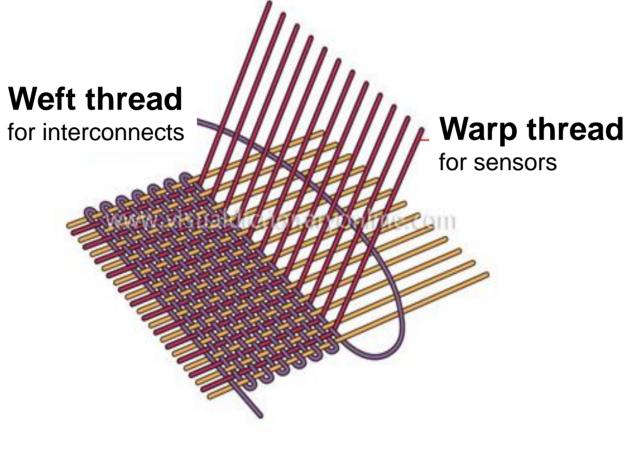
Industrial Textiles with electronic components

Inkjet printed capacitive strain sensors

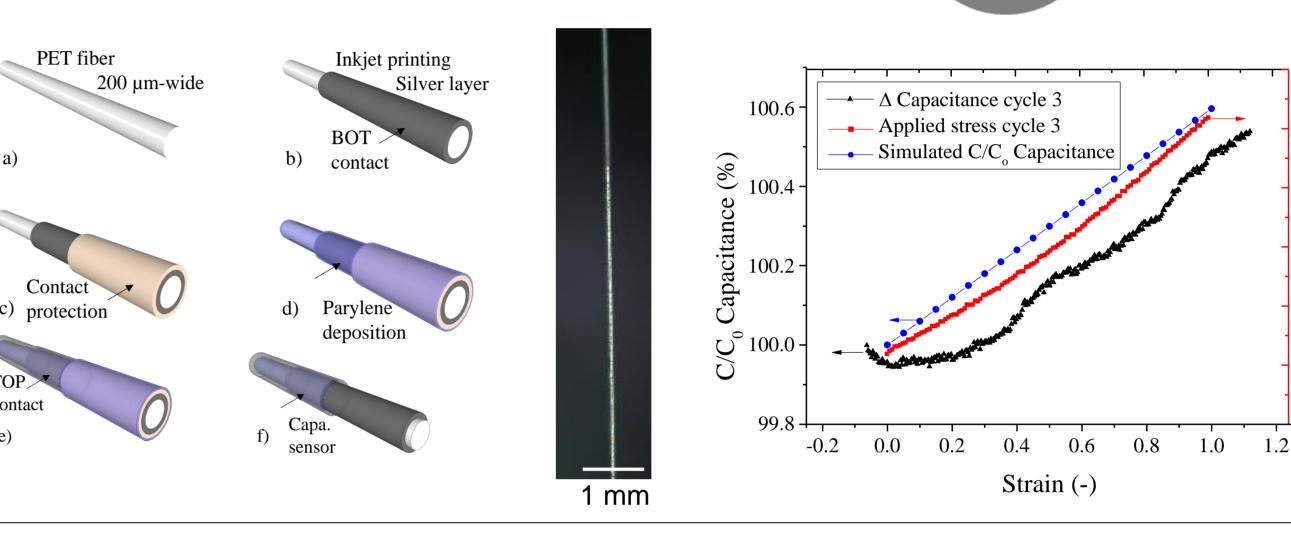
NTF

large – area textile for mechanical stimuli detection: sensors and TFTs fabricated on cylindrical fibres either by cleanroom technology or by printing techniques

- Functionalise 10 meters long fibers
- Weaving of functionalised fibers and their interconnects in industrial machine
 - Alignment procedure
 - Weaving pattern
 - Nature of textile
 - Type of machine
- Perform their electrical interconnections on woven textile

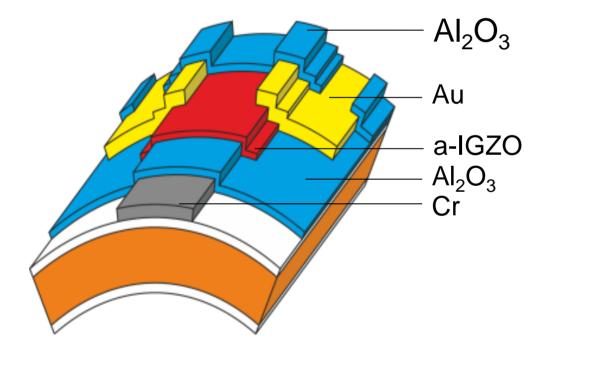


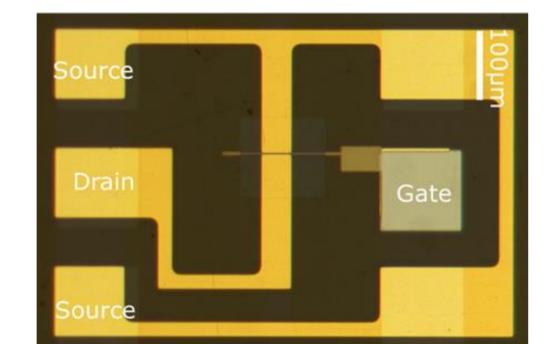
- **Substrate**: PET fibres (50 to 200 µm)
- **Dielectric**: parylene-C (2 µm)
- **Outer electrode**: Ag electrode around the fibre
- Inner electrode (PET core fibres): Ag electrode



Thin film transistors

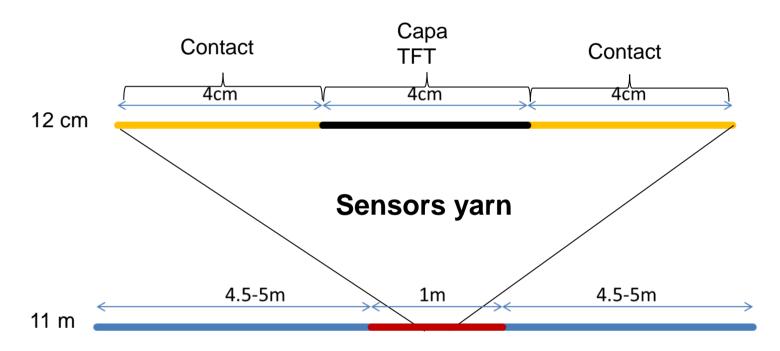
- **Substrate**: Polyimide (75 µm)
- **Gate dielectric**: ALD Al₂O₃
- Semiconductor: a-IGZO (~ 15 nm)
- Source and drain electrodes: 10 nm Ti + 60 nm Au
- Gate: Cr

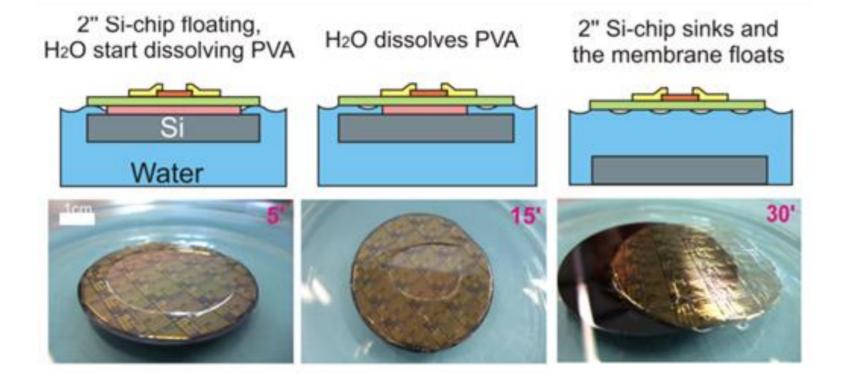




Weaving process and electrical connections



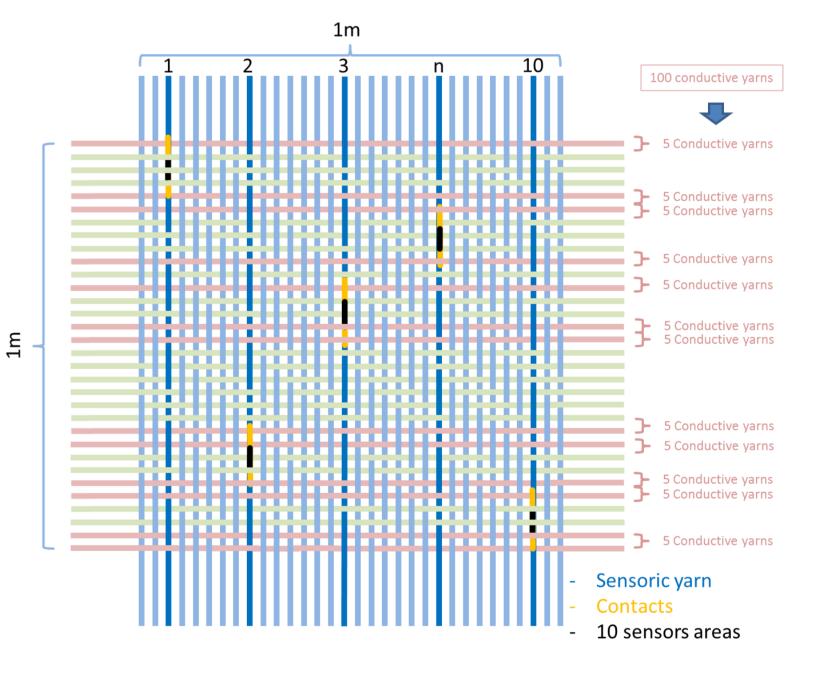




1 m x 1 m smart textile woven at SEFAR AG

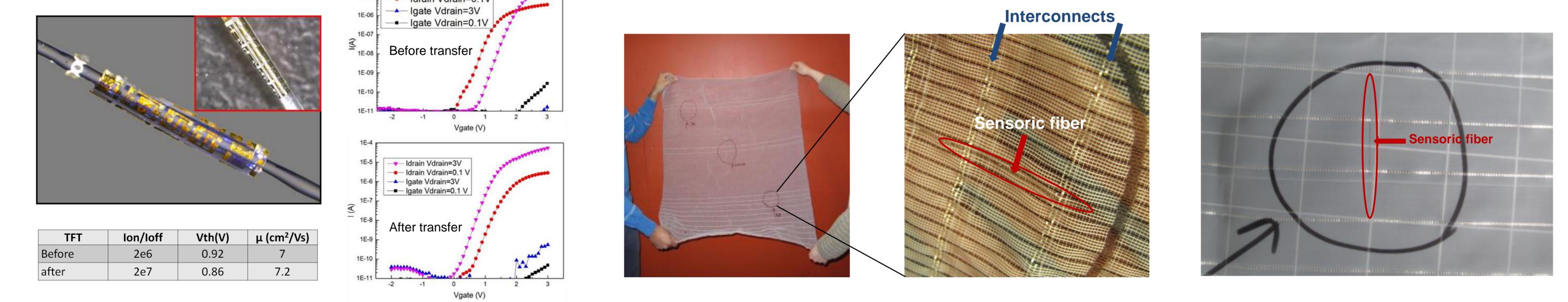
Challenges:

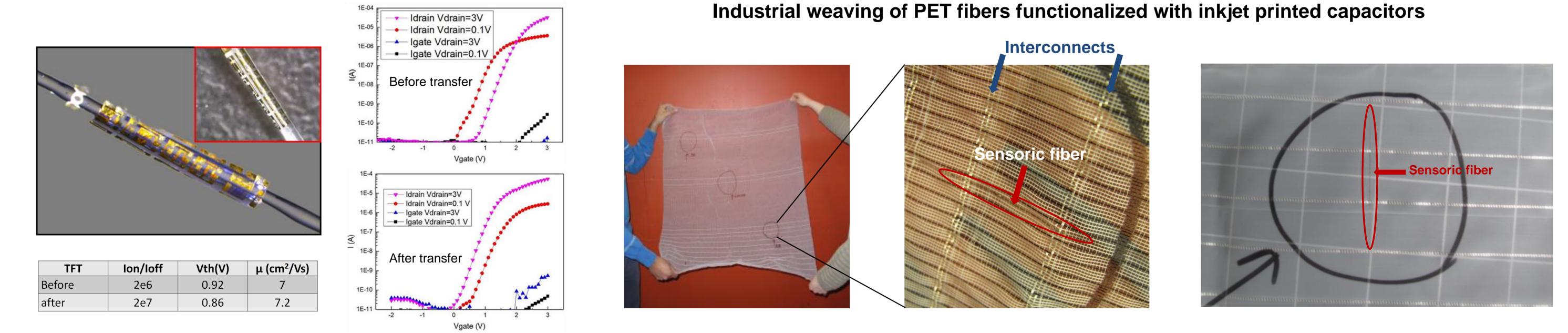
- Mechanical stress
- Mechanical friction
- Small bending radius
- Alignment

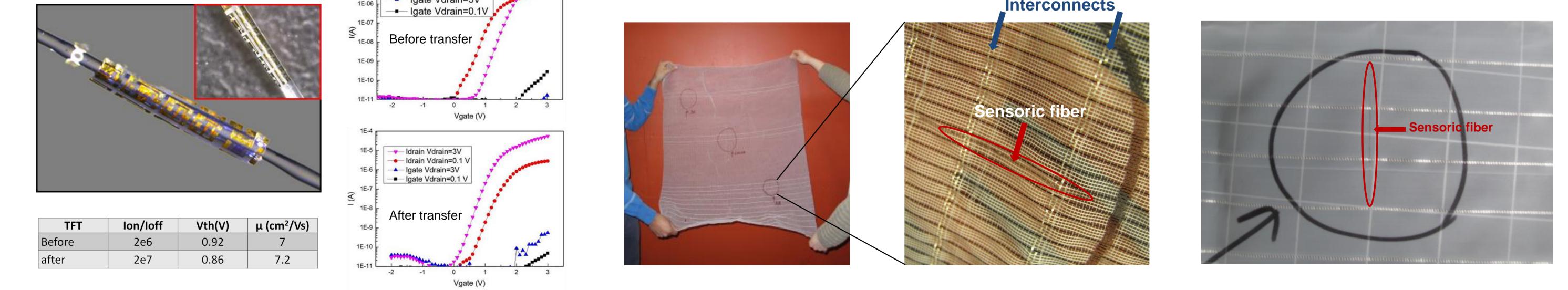


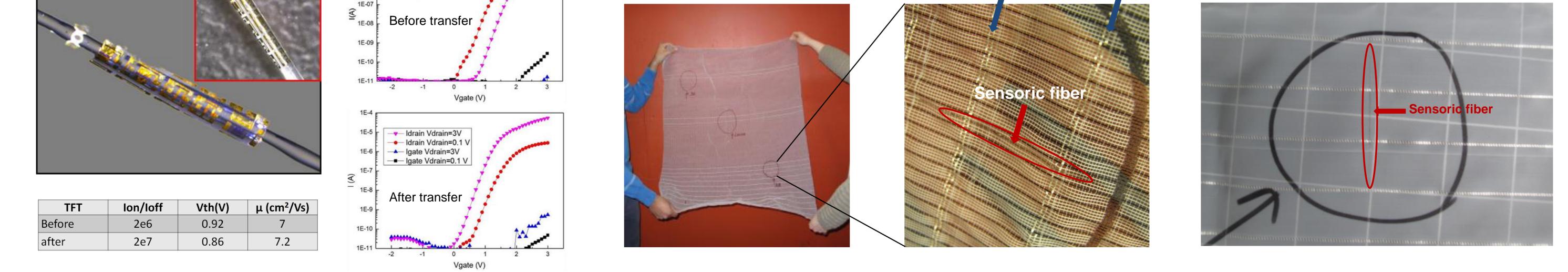
Demonstration











Conclusions

- Direct fabrication of capacitors on fibers by inkjet-printing and characterisation of their performances as strain sensors
- TFTs on foil transferred on cylindrical fibers by wrapping and comparison of characteristics before and after transfer
- Weaving of 10 meters long functionalized fibers using an industrial machine with proper alignment
- Overall robustness of the functionalized fibers requires improvements to be fully operational after weaving process
- We are considering to apply additive processes (e.g. printing) to functionalise the textile after its weaving